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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

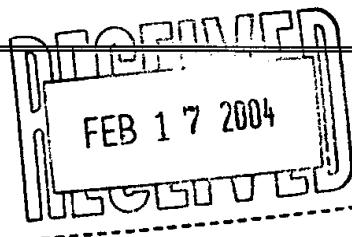
Applicant: Christoph Wasshuber, et al. Docket No: TI-31016
Serial No: 10/020,111 Conf. No: 5837
Examiner: Richard A. Booth Art Unit: 2812
Filed: 12/14/2001
For: METHODS AND APPARATUS FOR INDUCING STRESS IN A SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 1-26-04.

Ann Trent
Ann Trent



Dear Sir:

Responsive to the Office Action mailed November 7, 2003, in connection with the above identified application, Applicants respectfully submit the following remarks.

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